



**ELECTRONIC COPY**

LG758587812  
Report verification at igi.org



December 24, 2025

IGI Report Number **LG758587812**

Description **LABORATORY GROWN DIAMOND**

Shape and Cutting Style **CUT CORNERED  
RECTANGULAR MODIFIED  
BRILLIANT**

Measurements **9.98 X 7.38 X 4.89 MM**

**GRADING RESULTS**

Carat Weight **3.09 CARATS**

Color Grade **E**

Clarity Grade **VS 1**

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Clarity Grade **VS 1**

**ADDITIONAL GRADING INFORMATION**

Polish **EXCELLENT**

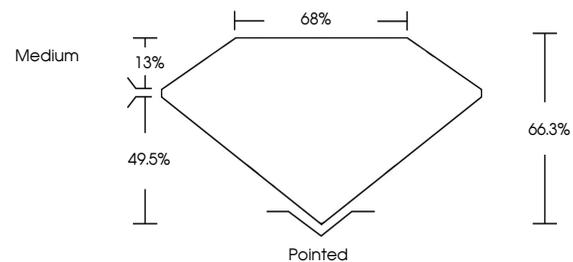
Symmetry **EXCELLENT**

Fluorescence **NONE**

Inscription(s) **IGI LG758587812**

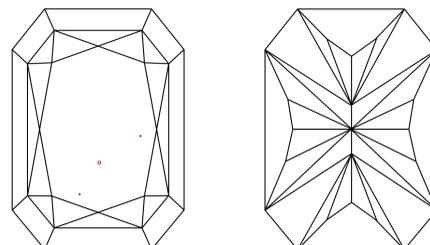
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.  
Type IIa

**PROPORTIONS**



Sample Image Used

**CLARITY CHARACTERISTICS**



**KEY TO SYMBOLS**

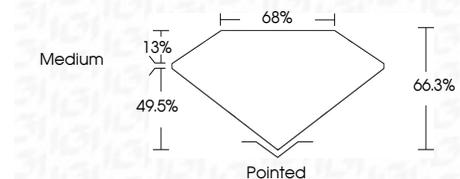
Red symbols indicate internal characteristics.  
Green symbols indicate external characteristics.

**COLOR**

D E F G H I J Faint Very Light Light

**CLARITY**

FL	IF	VS <sup>1-2</sup>	VS <sup>1-2</sup>	SI <sup>1-2</sup>	I <sup>1-3</sup>
Flawless	Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included



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**IGI**



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CUT CORNERED RECT. MODIFIED BRILLIANT  
3.09 CARATS E  
Color Grade E  
Clarity Grade VS 1  
Table 66.3%  
Depth 49.5%  
Width 68%  
Height 66.3%  
Medium  
Culet Pointed  
Polish EXCELLENT  
Symmetry EXCELLENT  
Fluorescence NONE  
Inscription(s) IGI LG758587812  
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